

Docket No.: RSW-S3019

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : MAIK STEGEMANN ET AL.  
Filed : CONCURRENTLY HEREWITH  
Title : METHOD FOR FABRICATING A SEMICONDUCTOR STRUCTURE

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In accordance with 37 C.F.R. 1.98 copies of the following patents and/or publications are submitted herewith:

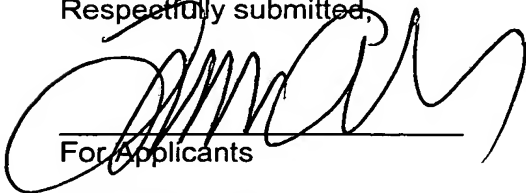
U.S. Patent No. 5,378,316 (Franke et al.), dated January 3, 1995;

U.S. Patent No. 6,159,863 (Chen et al.), dated December 12, 2000;

U.S. Patent No. 6,042,993 (Leuschner et al.), dated March 28, 2000, and corresponding European Patent Application EP 0 808 481 B1 (Leuschner et al.), dated November 26, 1997.

As per the Notice in 1273 OG 55 (August 5, 2003) no copies of any above-mentioned U.S. patents and U.S. patent application publications are submitted for any application filed after June 30, 2003.

Respectfully submitted,



For Applicants

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<b>FORM PTO-1449 (SUBSTITUTE)</b>  U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE  <b>INFORMATION DISCLOSURE          STATEMENT BY APPLICANT</b> (37 CFR 1.98(b))				Attorney Docket No.: RSW-S3019 Appl. No.:  <hr/> Applicant: MAIK STEGEMANN ET AL.  <hr/> Filing Date: March 22, 2004 Group Art Unit:			
EXAMINER INITIALS		PATENT NO.	DATE	PATENTEE	CLASS	SUB CLASS	FILING DATE
	A	5,378,316	1/3/95	Franke et al.			
	B	6,159,863	12/12/00	Chen et al.			
	C	6,042,993	3/28/00	Leuschner et al.			
	D						
	E						
	F						
	G						
	H						
	I						
<b>FOREIGN PATENT DOCUMENT</b>							
		DOCUMENT NO.	DATE	COUNTRY	CLASS	SUB CLASS	TRANSL. YES   NO
	J	0 808 481 B1	11/26/97	Europe			
	K						
	L						
	M						
	N						
<b>OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)</b>							
<b>EXAMINER</b>				<b>DATE CONSIDERED</b>			